

Title (en)

METHOD AND SYSTEM TO DETECT SUBSTRATE PLACEMENT ACCURACY

Title (de)

VERFAHREN UND SYSTEM ZUR ERKENNUNG DER POSITIONIERGENAUIGKEIT EINES SUBSTRATS

Title (fr)

PROCÉDÉ ET SYSTÈME POUR DÉTECTER UNE PRÉCISION DE PLACEMENT DE SUBSTRAT

Publication

**EP 3542204 B1 20210217 (EN)**

Application

**EP 17807764 A 20171116**

Priority

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Abstract (en)

[origin: WO2018091586A1] A method and system for measuring the alignment between a substrate (102) and a platform (104) upon which it is disposed by using image processing algorithms are described herein. These algorithms automate the detection of edges (112 and 114) of a microscope slide and the platform (106 and 108) in a digital image (100). A reference line pattern (110) in an image of the platform can be used to detect platform edges (106 and 108) based on a computed location of the reference line pattern in the image.

IPC 8 full level

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CPC (source: EP US)

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